

## APPLICATION DATA SHEET

### Inventor Information

Inventor One Given Name:: Jin-goo  
Family Name:: Park  
Name Suffix::  
Postal Address Line One:: 402-1501, Hyundai2-cha Apt., Sa-dong,  
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Citizenship Country:: Korean

Inventor Two Given Name:: Dae-hong  
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Name Suffix::  
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State or Province::  
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Inventor Three Given Name:: Jae-hwa  
Family Name:: LEE  
Name Suffix::  
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State or Province::  
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Inventor Four Given Name:: Neung-goo  
Family Name:: YOON  
Name Suffix::  
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City::  
State or Province::  
Country:: Republic of Korea  
Postal or Zip Code 459-824  
Citizenship Country:: Korean

### **Correspondence Information**

Correspondence Customer Number:: 6449

### **Application Information**

Title Line One:: SEMICONDUCTOR WAFER CLEANING APPARATUS AND  
Title Line Two:: CLEANING METHOD USING THE SAME  
Total Drawing Sheets:: 1  
Formal Drawings?:: YES  
Application Type:: Utiliy  
Docket Number:: 1751-297

Secrecy Order in Parent Appl?:: NO

### **Representative Information**

Representative Customer Number:: 6449